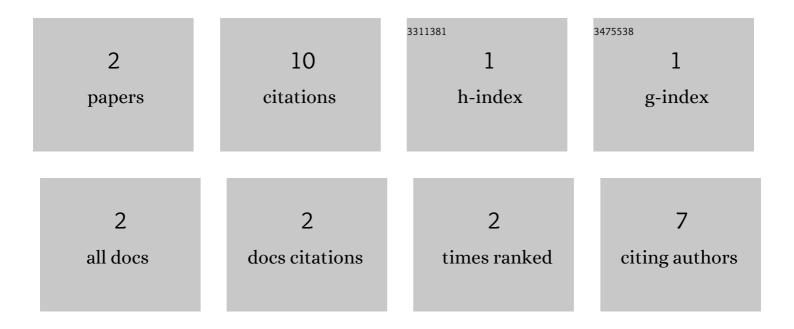
Diana Mata-Hernandez

List of Publications by Year in descending order

Source: https://exaly.com/author-pdf/6537848/publications.pdf Version: 2024-02-01



#	Article	IF	CITATIONS
1	Resonant MEMS Pressure Sensor in 180 nm CMOS Technology Obtained by BEOL Isotropic Etching. Sensors, 2020, 20, 6037.	3.8	7
2	Hardware-Software Co-Design for Efficient and Scalable Real-Time Emulation of SNNs on the Edge. , 2021, , .		3